Joel T Asubar

List of Publications by Year in descending order

Source: https://exaly.com/author-pdf/3271446/publications.pdf Version: 2024-02-01



LOFI T ASURAD

| # | Article | IF | CITATIONS |
|----|---|-----|-----------|
| 1 | Insulated gate and surface passivation structures for GaN-based power transistors. Journal Physics D: Applied Physics, 2016, 49, 393001. | 1.3 | 172 |
| 2 | AlGaN/GaN high-electron-mobility transistor technology for high-voltage and low-on-resistance operation. Japanese Journal of Applied Physics, 2016, 55, 070101. | 0.8 | 103 |
| 3 | Highly-stable and low-state-density Al2O3/GaN interfaces using epitaxial n-GaN layers grown on free-standing GaN substrates. Applied Physics Letters, 2016, 109, 162104. | 1.5 | 83 |
| 4 | Current Stability in Multi-Mesa-Channel AlGaN/GaN HEMTs. IEEE Transactions on Electron Devices, 2013, 60, 2997-3004. | 1.6 | 79 |
| 5 | Characterization of electronic states at insulator/(Al)GaN interfaces for improved insulated gate and surface passivation structures of GaN-based transistors. Japanese Journal of Applied Physics, 2014, 53, 100213. | 0.8 | 76 |
| 6 | Controlling surface/interface states in GaN-based transistors: Surface model, insulated gate, and surface passivation. Journal of Applied Physics, 2021, 129, . | 1.1 | 58 |
| 7 | MBE growth of Mn-doped ZnSnAs2 thin films. Journal of Crystal Growth, 2009, 311, 929-932. | 0.7 | 42 |
| 8 | Large As sublattice distortion in sphalerite ZnSnAs2 thin films revealed by x-ray fluorescence holography. Journal of Applied Physics, 2016, 119, . | 1.1 | 40 |
| 9 | Enhancement-Mode AlGaN/GaN MIS-HEMTs With High V _{TH} and High I _{Dmax} Using Recessed-Structure With Regrown AlGaN Barrier. IEEE Electron Device Letters, 2020, 41, 693-696. | 2.2 | 39 |
| 10 | Reduced thermal resistance in AlGaN/GaN multi-mesa-channel high electron mobility transistors. Applied Physics Letters, 2014, 105, 053510. | 1.5 | 33 |
| 11 | Current Collapse Reduction in AlGaN/GaN HEMTs by High-Pressure Water Vapor Annealing. IEEE Transactions on Electron Devices, 2015, 62, 2423-2428. | 1.6 | 31 |
| 12 | MBE growth of Mn-doped Zn–Sn–As compounds on (001) InP substrates. Journal of Crystal Growth, 2007, 301-302, 656-661. | 0.7 | 24 |
| 13 | Impact of oxygen plasma treatment on the dynamic on-resistance of AlGaN/GaN high-electron-mobility transistors. Applied Physics Express, 2015, 8, 111001. | 1.1 | 22 |
| 14 | Zinc-blende MnAs thin films directly grown on InP (001) substrates as possible source of spin-polarized current. Journal of Crystal Growth, 2012, 338, 129-133. | 0.7 | 21 |
| 15 | AlGaN/GaN metal–insulator–semiconductor high-electron mobility transistors with high on/off current ratio of over 5 × 10 ¹⁰ achieved by ozone pretreatment and using ozone oxidant for Al ₂ O ₃ gate insulator. Japanese Journal of Applied Physics, 2016, 55, 120305. | 0.8 | 21 |
| 16 | Interface trap states in Al ₂ O ₃ /AlGaN/GaN structure induced by inductively coupled plasma etching of AlGaN surfaces. Physica Status Solidi (A) Applications and Materials Science, 2015, 212, 1075-1080. | 0.8 | 20 |
| 17 | Electrotransport Properties of p-ZnSnAs ₂ Thin Films Grown by Molecular Beam Epitaxy on Semi-insulating (001) InP Substrates. Japanese Journal of Applied Physics, 2008, 47, 657. | 0.8 | 18 |
| 18 | Highly reduced current collapse in AlGaN/GaN high-electron-mobility transistors by combined application of oxygen plasma treatment and field plate structures. Japanese Journal of Applied Physics, 2016, 55, 04EG07. | 0.8 | 17 |

JOEL T ASUBAR

| # | Article | IF | CITATIONS |
|----|--|-----|-----------|
| 19 | Impurity band conduction and negative magnetoresistance in pâ€ZnSnAs ₂ thin films. Physica Status Solidi C: Current Topics in Solid State Physics, 2009, 6, 1158-1161. | 0.8 | 15 |
| 20 | MBE growth and properties of GaMnAs with high level of Zn acceptor incorporation. Physica Status Solidi (A) Applications and Materials Science, 2006, 203, 2778-2782. | 0.8 | 13 |
| 21 | High-Resolution X-ray Diffraction Studies of ZnSnAs2 Epitaxial Films Nearly Lattice-matched to InP Substrates. Physics Procedia, 2010, 3, 1351-1356. | 1.2 | 13 |
| 22 | Effect of thermal annealing on the properties of narrow-bandgap ZnSnAs2 epitaxial films on InP(001) substrates. Physics Procedia, 2010, 3, 1341-1344. | 1.2 | 12 |
| 23 | On the presence of Ga2O sub-oxide in high-pressure water vapor annealed AlGaN surface by combined XPS and first-principles methods. Applied Surface Science, 2019, 481, 1120-1126. | 3.1 | 11 |
| 24 | Design considerations for normally-off operation in Schottky gate p-GaN/AlGaN/GaN HEMTs. Japanese Journal of Applied Physics, 2020, 59, 084002. | 0.8 | 11 |
| 25 | Evaluation of off-bias-stress induced surface charging at AlGaN/GaN surface using a dual-gate transistor structure. Japanese Journal of Applied Physics, 2014, 53, 070301. | 0.8 | 9 |
| 26 | GaN-based MIS-HEMTs with Al ₂ O ₃ dielectric deposited by low-cost and environmental-friendly mist-CVD technique. Applied Physics Express, 2021, 14, 031004. | 1.1 | 9 |
| 27 | Anomalous Hall Effect and Magnetoresistance in Mn-Doped ZnSnAs ₂ Epitaxial Film on InP Substrates. Japanese Journal of Applied Physics, 2011, 50, 01BE12. | 0.8 | 9 |
| 28 | Electron concentration in highly resistive GaN substrates co-doped with Si, C, and Fe. Japanese Journal of Applied Physics, 2018, 57, 071001. | 0.8 | 8 |
| 29 | Three Dimensional Local Structure Analysis of ZnSnAs ₂ :Mn by X-ray Fluorescence Holography. Japanese Journal of Applied Physics, 2011, 50, 01BF05. | 0.8 | 8 |
| 30 | Influence of reactive-ion-etching depth on interface properties in Al ₂ O ₃ /n-GaN MOS diodes. Japanese Journal of Applied Physics, 2019, 58, 106503. | 0.8 | 7 |
| 31 | MBE growth and properties of GeMn thin films on (001) GaAs. Journal of Crystal Growth, 2009, 311, 937-940. | 0.7 | 6 |
| 32 | Generalized Frequency Dependent Small Signal Model for High Frequency Analysis of AlGaN/GaN MOS-HEMTs. IEEE Journal of the Electron Devices Society, 2021, 9, 570-581. | 1.2 | 6 |
| 33 | Room-Temperature Ferromagnetism in (Zn,Mn,Sn)As2Thin Films Applicable to InP-Based Spintronic Devices. Japanese Journal of Applied Physics, 2011, 50, 05FB02. | 0.8 | 5 |
| 34 | Improved current stability in multi-mesa-channel AlGaN/GaN transistors. Physica Status Solidi C: Current Topics in Solid State Physics, 2014, 11, 857-861. | 0.8 | 5 |
| 35 | Current collapse in AlGaN/GaN HEMTs with a GaN cap layer. , 2015, , . | | 5 |
| 36 | Improved current collapse in AlGaN/GaN HEMTs with 3-dimensional field plate structure. , 2015, , . | | 5 |

Improved current collapse in AlGaN/GaN HEMTs with 3-dimensional field plate structure. , 2015, , . 36

JOEL T ASUBAR

| # | Article | IF | CITATIONS |
|----|---|-----|-----------|
| 37 | Magnetic phase change in Mn-doped ZnSnAs2 thin films depending on Mn concentration. Journal of Applied Physics, 2018, 123, . | 1.1 | 5 |
| 38 | Enhancementâ€Mode AlGaN/GaN Vertical Trench Metal–Insulator–Semiconductor Highâ€Electronâ€Mobility Transistors with a High Drain Current Fabricated Using the AlGaN Regrowth Technique. Physica Status Solidi (A) Applications and Materials Science, 2020, 217, 1900622. | 0.8 | 5 |
| 39 | Annealing Effects on Impurity Band Conduction of ZnSnAs ₂ Epitaxial Films. IOP Conference Series: Materials Science and Engineering, 2011, 21, 012031. | 0.3 | 4 |
| 40 | Ferromagnetic ZnSnAs2:Mn Chalcopyrite Semiconductors for InP-based Spintronics. E-Journal of Surface Science and Nanotechnology, 2011, 9, 95-102. | 0.1 | 4 |
| 41 | Correlation of AlGaN/GaN high-electron-mobility transistors electroluminescence characteristics with current collapse. Applied Physics Express, 2018, 11, 024101. | 1.1 | 4 |
| 42 | Anomalous Hall Effect and Magnetoresistance in Mn-Doped ZnSnAs2Epitaxial Film on InP Substrates. Japanese Journal of Applied Physics, 2011, 50, 01BE12. | 0.8 | 3 |
| 43 | High drain current and low on-resistance in AlGaN/GaN HEMTs with Au-plated ohmic electrodes. , 2015, , . | | 3 |
| 44 | Calculating relaxation time distribution function from power spectrum based on inverse integral transformation method. Physics Letters, Section A: General, Atomic and Solid State Physics, 2015, 379, 738-742. | 0.9 | 3 |
| 45 | Reduced current collapse in multi-fingered AlGaN/GaN MOS-HEMTs with dual field plate. , 2017, , . | | 3 |
| 46 | Analytical derivation of interface state density from sub-threshold swing in AlGaN/GaN metal–insulator–semiconductor high-electron-mobility transistors. Japanese Journal of Applied Physics, 2017, 56, 104101. | 0.8 | 3 |
| 47 | Modified Small Signal Circuit of AlGaN/GaN MOS-HEMTs Using Rational Functions. IEEE Transactions on Electron Devices, 2021, 68, 6059-6064. | 1.6 | 3 |
| 48 | Comparison of annealing effects on Zn-doped GaMnAs and undoped GaMnAs epilayers. Applied Surface Science, 2008, 254, 6648-6652. | 3.1 | 2 |
| 49 | Low-temperature annealing effects on (Ga,Mn)As/Zn-GaAs superlattice structures grown on GaAs(001) substrates. Journal of Crystal Growth, 2009, 311, 933-936. | 0.7 | 2 |
| 50 | Three Dimensional Local Structure Analysis of ZnSnAs2:Mn by X-ray Fluorescence Holography. Japanese Journal of Applied Physics, 2011, 50, 01BF05. | 0.8 | 2 |
| 51 | High breakdown voltage AlGaN/GaN HEMTs on free-standing GaN substrate. , 2015, , . | | 2 |
| 52 | Study on Threshold Voltage Hysteresis in GaN-Based Vertical Trench MOSFETs. , 2018, , . | | 2 |
| 53 | Improved Current Collapse in AlGaN/GaN MOS-HEMTs with Dual Field-Plates. , 2018, , . | | 2 |
| 54 | Spatial distribution of substitutional Mn-As clusters in ferromagnetic (Zn,Sn,Mn)As2 thin films revealed by image reconstruction of atom probe tomography data. Journal of Applied Physics, 2019, 125, 073902. | 1.1 | 2 |

JOEL T ASUBAR

| # | Article | IF | CITATIONS |
|----|---|-----|-----------|
| 55 | Impact of SiN capping during Ohmic Annealing on Performance of GaN-based MISHEMTs. , 2019, , . | | 2 |
| 56 | Epitaxial growth and characterization of Cr-doped ZnSnAs2thin films on InP substrates. Japanese Journal of Applied Physics, 2020, 59, 030601. | 0.8 | 2 |
| 57 | Room-Temperature Ferromagnetism in (Zn,Mn,Sn)As2Thin Films Applicable to InP-Based Spintronic Devices. Japanese Journal of Applied Physics, 2011, 50, 05FB02. | 0.8 | 2 |
| 58 | Effect of metal electrode edge irregularities on breakdown voltages of AlGaN/GaN HEMTs. , 2016, , . | | 1 |
| 59 | Breakdown degradation of AlGaN/GaN HEMTs with multi-finger gate patterns. , 2016, , . | | 1 |
| 60 | Analytical derivation of charge relaxation time distribution in transistor from current noise spectrum using inverse integral transformation method. Applied Physics Express, 2018, 11, 031201. | 1.1 | 1 |
| 61 | Impact of rounded electrode corners on breakdown characteristics of AlGaN/GaN high-electron mobility transistors. Applied Physics Express, 2018, 11, 054102. | 1.1 | 1 |
| 62 | Stoichiometric imbalances in Mg-implanted GaN. Japanese Journal of Applied Physics, 2021, 60, 066504. | 0.8 | 1 |
| 63 | Ornstein–Uhlenbeck process in a human body weight fluctuation. Physica A: Statistical Mechanics and Its Applications, 2021, 582, 126286. | 1.2 | 1 |
| 64 | Fabrication and structural characterization of nearly lattice-matched p-ZnSnAs2/n-InP heterojunctions. , 2009, , . | | 0 |
| 65 | Cu/Al/Mo/Au and Ni/Al/Mo/Au ohmic contacts for AlGaN/GaN heterostructures. , 2015, , . | | Ο |
| 66 | Impact of drain electrode shape irregularities on breakdown voltage of AlGaN/GaN HEMTs. , 2016, , . | | 0 |
| 67 | Effect of reverse bias annealing on the properties of AlGaN/GaN MIS-HEMTs with recessed-gate structure. , 2017, , . | | Ο |
| 68 | Characterization of Resistivity and Breakdown Field in Fe-Doped Semi-Insulating Gan Substrates. , 2018, , . | | 0 |
| 69 | Effect of Post-Gate Deposition Annealing on the Electrical Characteristics of AlGaN/GaN HEMTs with p-GaN Gate. , 2018, , . | | 0 |
| 70 | Improved linearity, stability, and thermal performance of multi-mesa-channel AlGaN/GaN HEMTs. , 2018, 1, . | | 0 |
| 71 | Mist chemical vapor deposited-Al ₂ O ₃ /AlGaN interfacial characterization for GaN MIS-HEMTs. , 2021, , . | | 0 |